
All Inkjet-printed, Transparent Piezoelectric Polymer Actuators for Microfluidic Lab-on-a-Chip Systems

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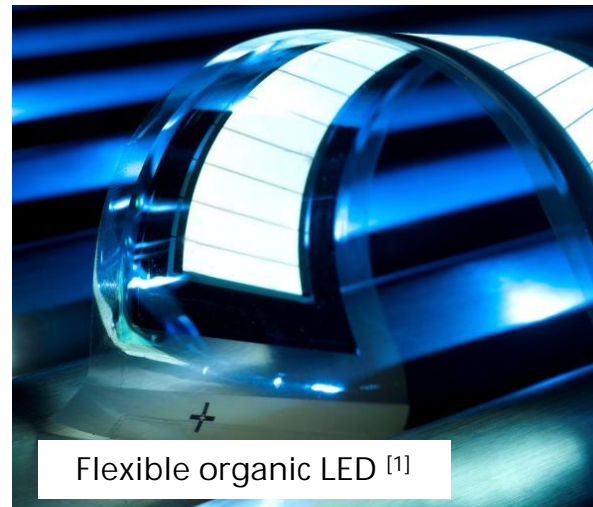
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Helsinki, Finland
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Printed and Organic Electronics

- Additive & flexible deposition
- Metal nanoparticles, conductive polymers, organic semiconductors, ...
- Ambient atmosphere
- Low processing temperatures

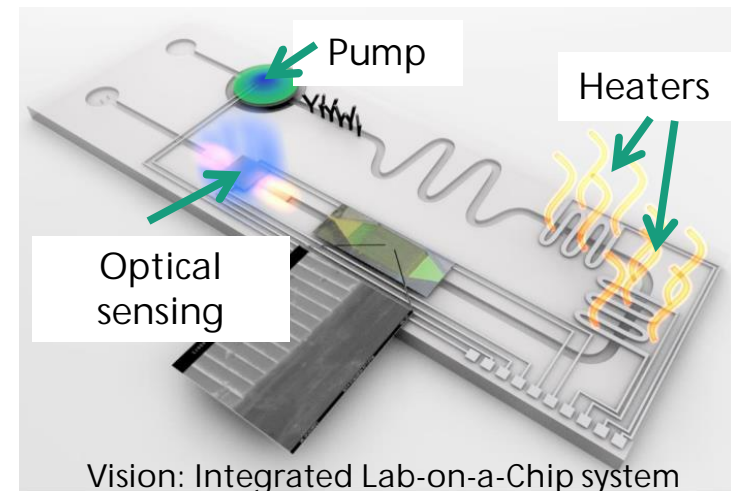
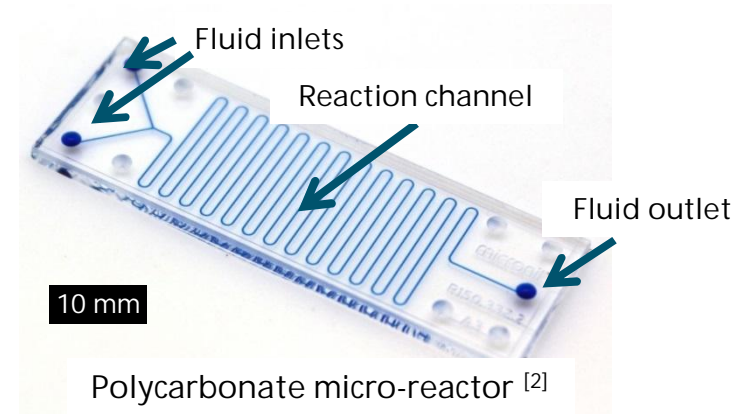


➔ Cost-effective solutions for disposable devices

Microfluidic Lab-on-a-Chip Systems (LOC)

- Point-of-care analysis in Life Sciences [1]
 - Disposable polymer chips
 - Currently: Many external functions
 - Key functions:
Fluid transport + temperature control

- Goal: On-chip function integration
 - Localized functionalities
 - Cost-efficient for disposable devices
 - Low processing temperatures

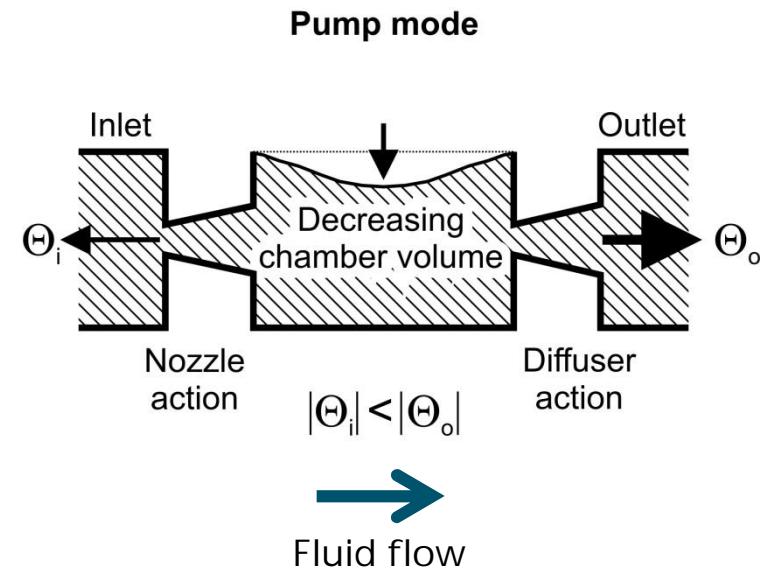
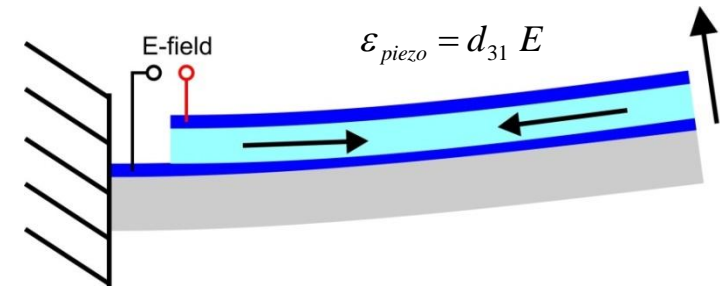


➔ Novel cost-effective and low-temperature processes required

Goal of Work

- Develop pump actuator for disposable LOC
 - Additive, inkjet-based process chain
 - Active material: Piezoelectric P(VDF-TrFE)
 - Transparent layer stack → optical detection
 - Characterize performance

- Set up pump demonstrator
 - No joining of separate actuator element
 - Target pump rate $10 - 100 \mu\text{L min}^{-1}$ [1]



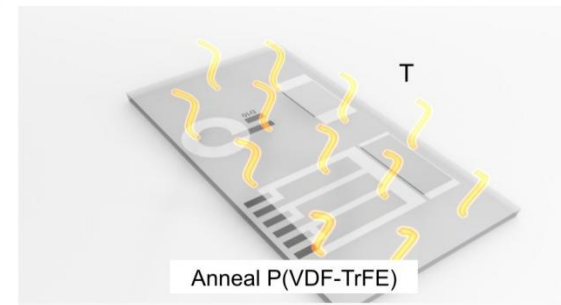
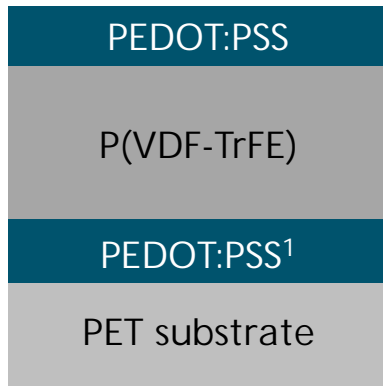
P(VDF-TrFE) – poly(vinylidene fluoride-co-trifluoroethylene)

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Basic Process Chain



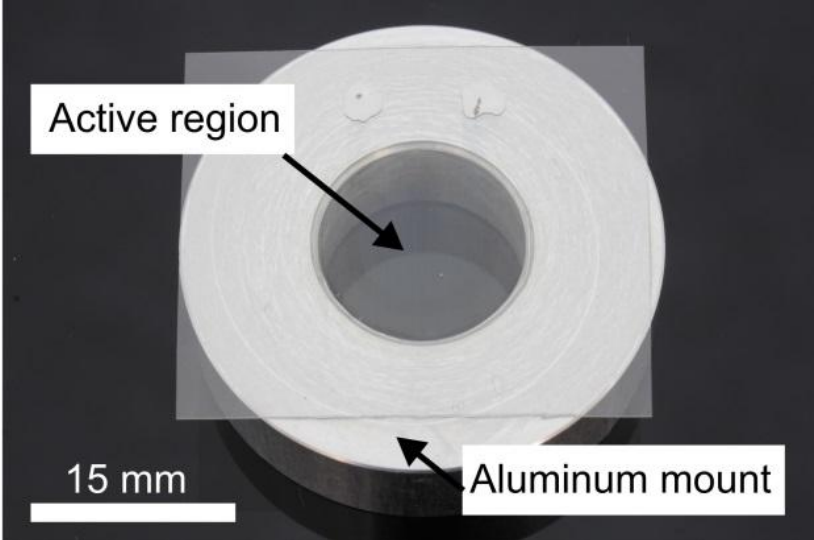
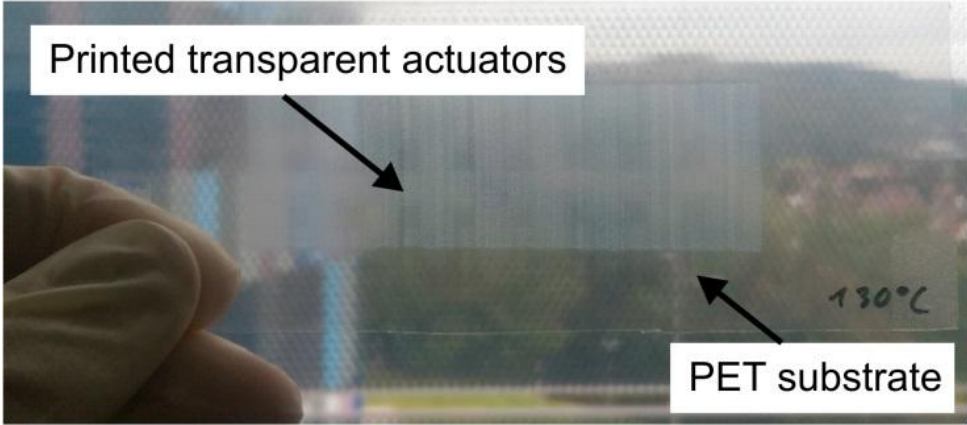
➔ Annealing P(VDF-TrFE): Performance vs. low-temperature processing

⁶ ¹ Clevios P Jet HCv2, Heraeus

PET – poly(ethylene terephthalate)

P(VDF-TrFE) – poly(vinylidene fluoride-co-trifluoroethylene)

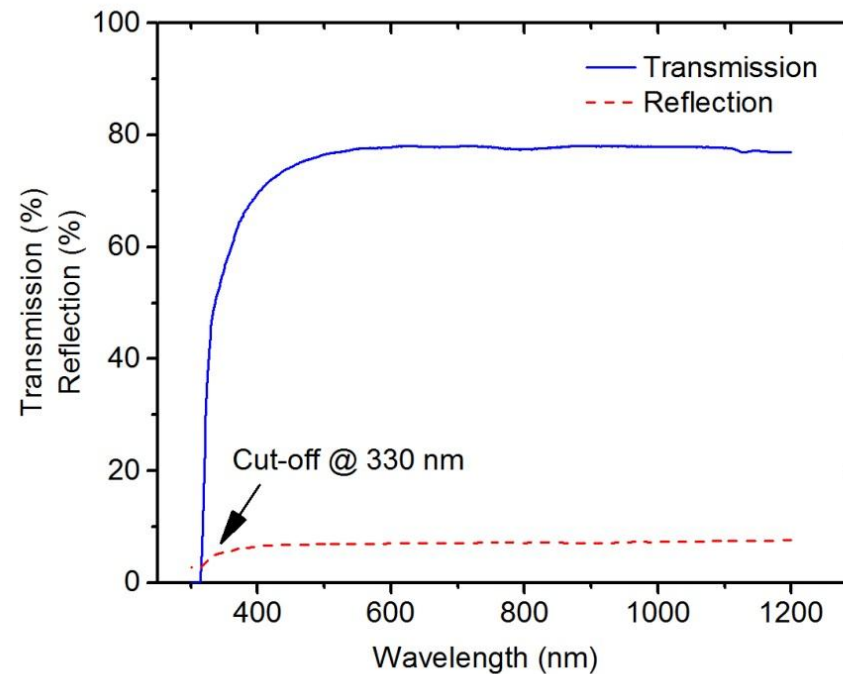
Processing – Fabricated Actuators



→ First fully inkjet-printed & transparent P(VDF-TrFE) actuators
Process chain suitable for polymer substrates

Device Performance - Optical

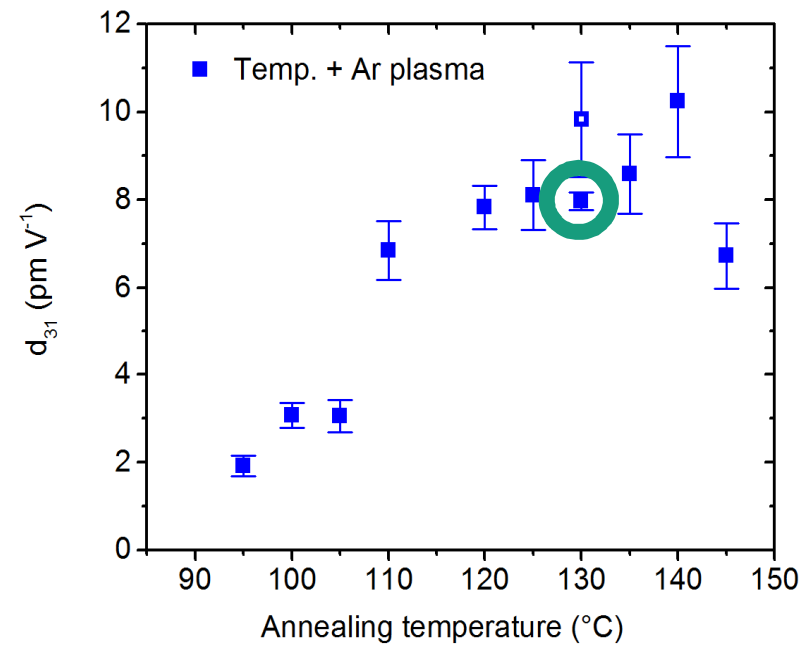
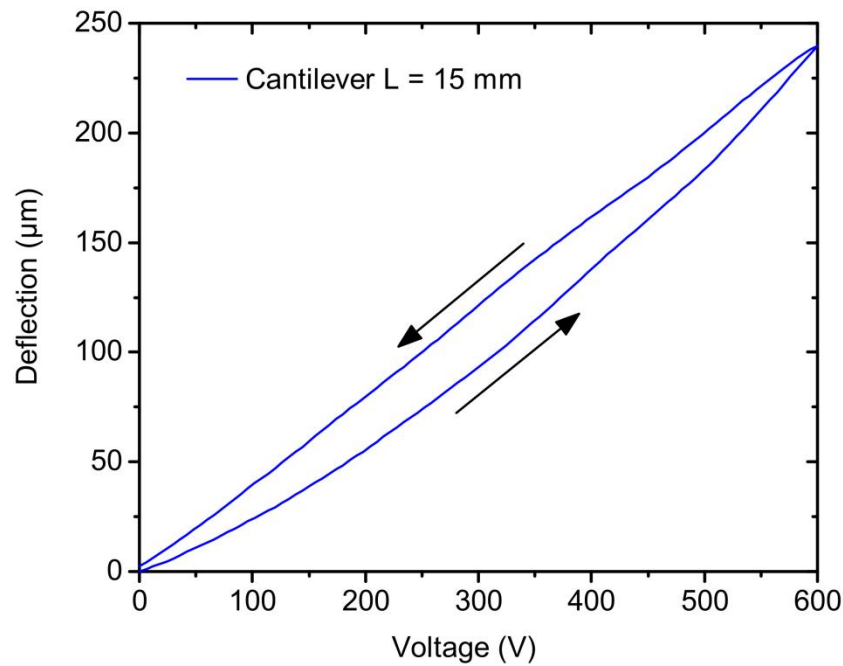
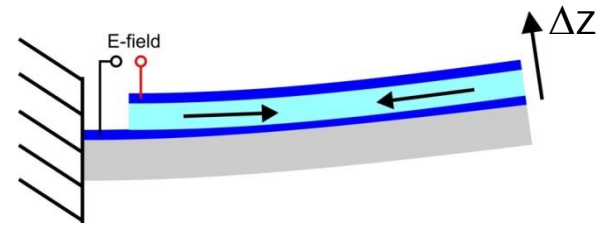
- Cut-off wavelength 300 nm
- > 75% transmission @ 460-1200 nm
- Substrate-only: 88% transmission



➔ Suitable for optical detection through actuator

Device Performance - Electromechanical

- Large d_{31} → Large actuator deflection Δz
- Measure Δz → derive d_{31}

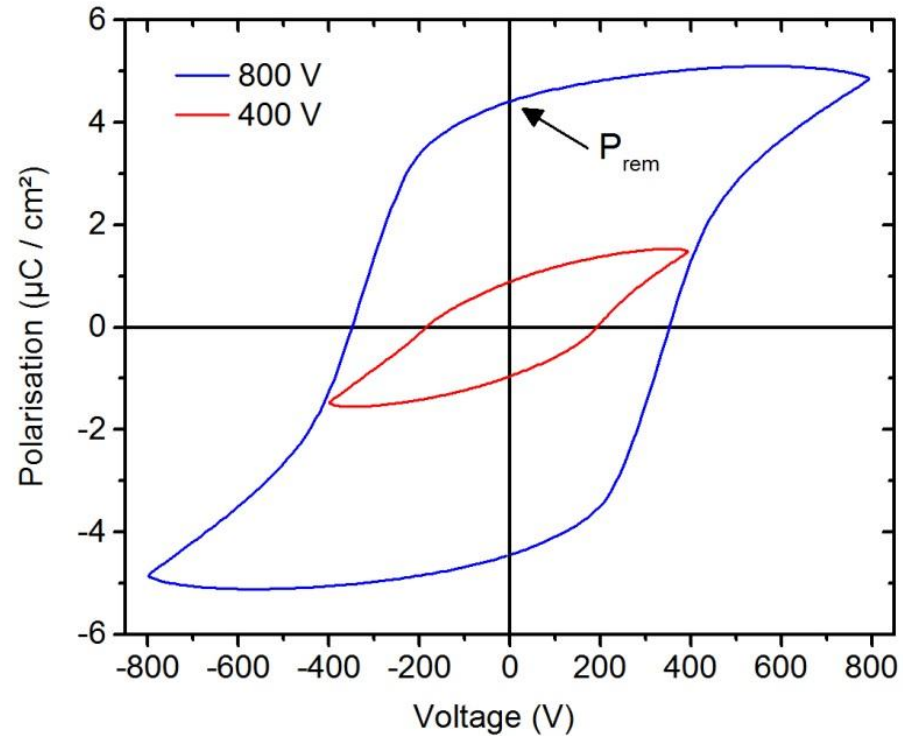


→ Annealing @ $110\text{ °C} \leq T \leq 145\text{ °C}$: Significant actuator performance

[Results obtained with silver electrodes]

Device Performance – Ferroelectric

- Ferroelectric hysteresis loops recorded up to 800 V / 89 kV mm⁻¹
- Remanent polarisation $P_{\text{rem}} = 4.4 \mu\text{C cm}^{-2}$

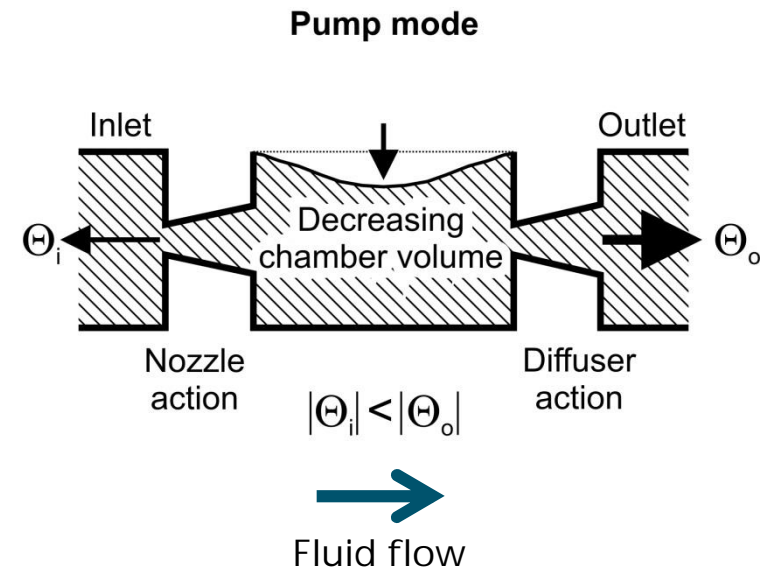


➔ Performance comparable to literature values

Goal of Work

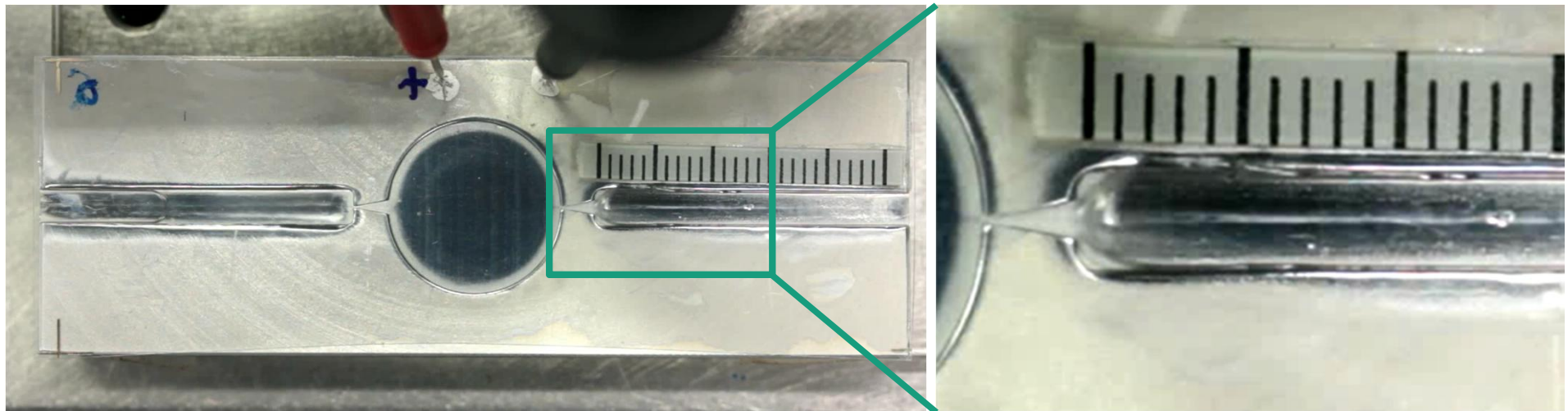
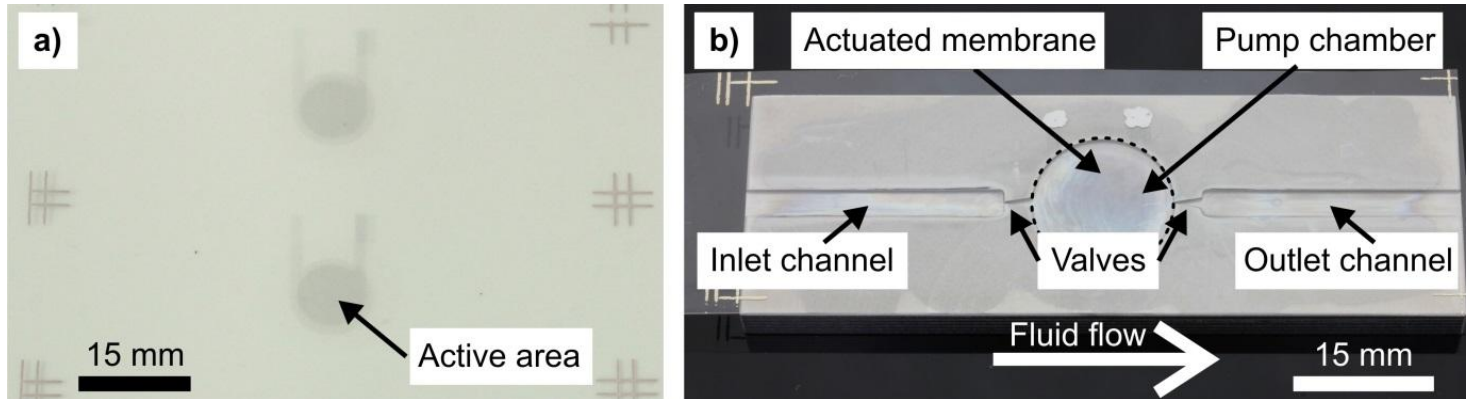
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Demonstrator: Micropump

- Milled pump substrate + printed membrane actuator

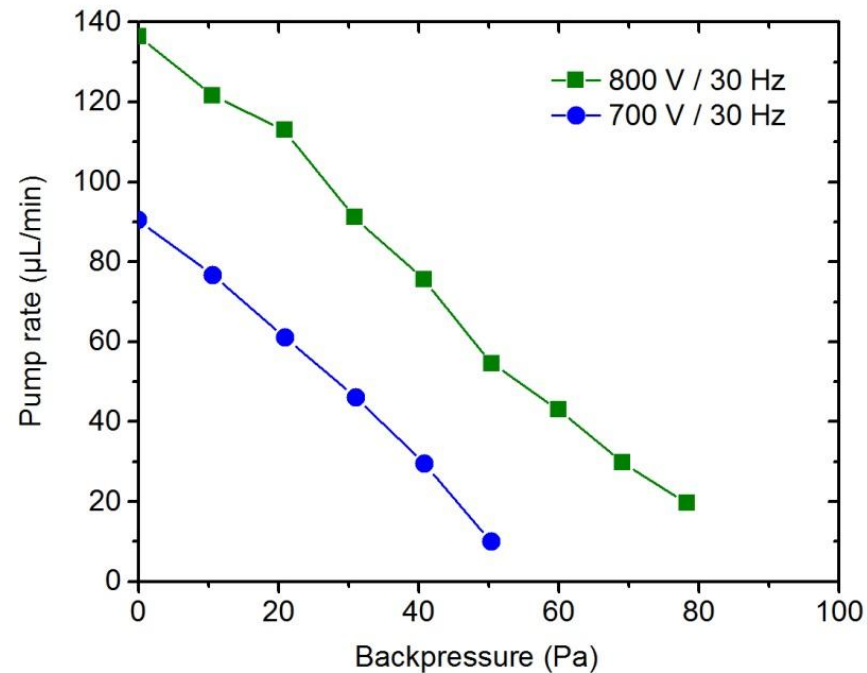


(*) Design based on A. Olsson, KTH Stockholm (1998).

Beckert, Pabst, Mikropumpe, Patent DE 102011107046 A1 (2013).

Pump Rate Measurements

- Pump rate vs. backpressure
- Maximum pump rate > 135 $\mu\text{L min}^{-1}$



Proof-of-concept: First transparent, inkjet-printed micropump actuator
Low backpressure due to passive valves → Modify valve concept

Conclusions

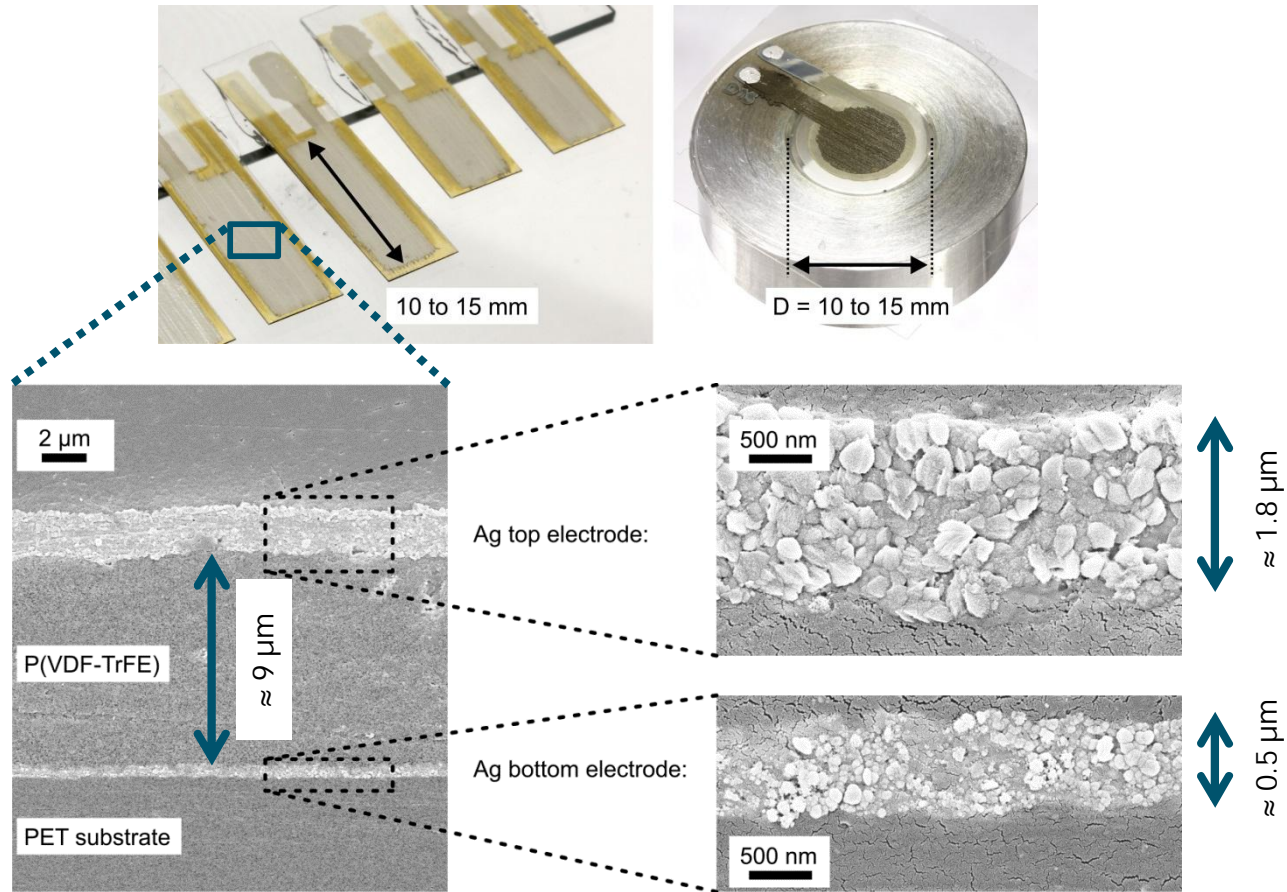
- Function integration in disposable, polymer-based LOC systems
 - Additive low-cost fabrication by inkjet-printed functions
 - Reduced hybrid integration
- Fully printed, transparent P(VDF-TrFE) actuators for micropumps
 - Transmission > 75% @ 460-1200 nm → optical detection through actuator
 - d_{31} coefficient up to 10 pm V⁻¹
- Demonstrator: First micropump with inkjet-printed, transparent actuator
 - Pump rates > 130 $\mu\text{L min}^{-1}$ → Suitable for LOC applications
 - Backpressure needs to be increased by optimized valves

Thank you for your attention!

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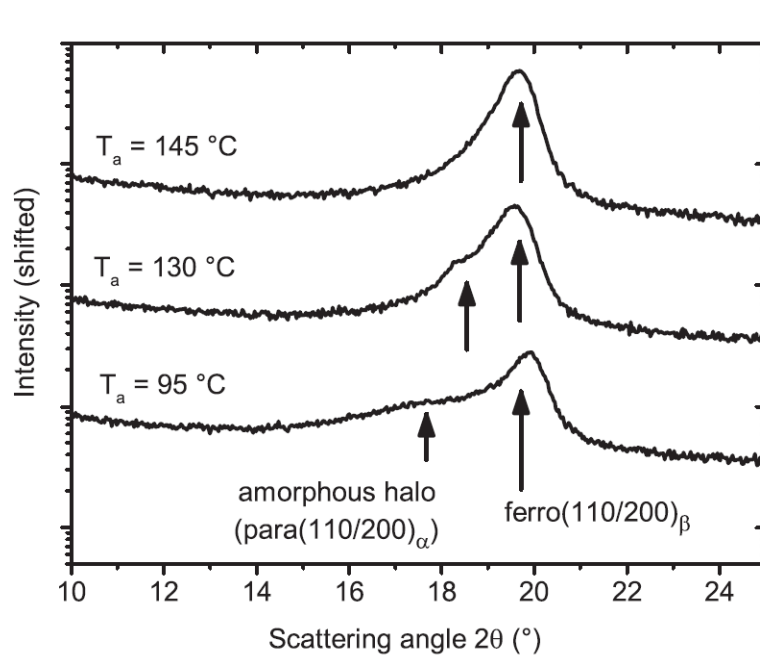
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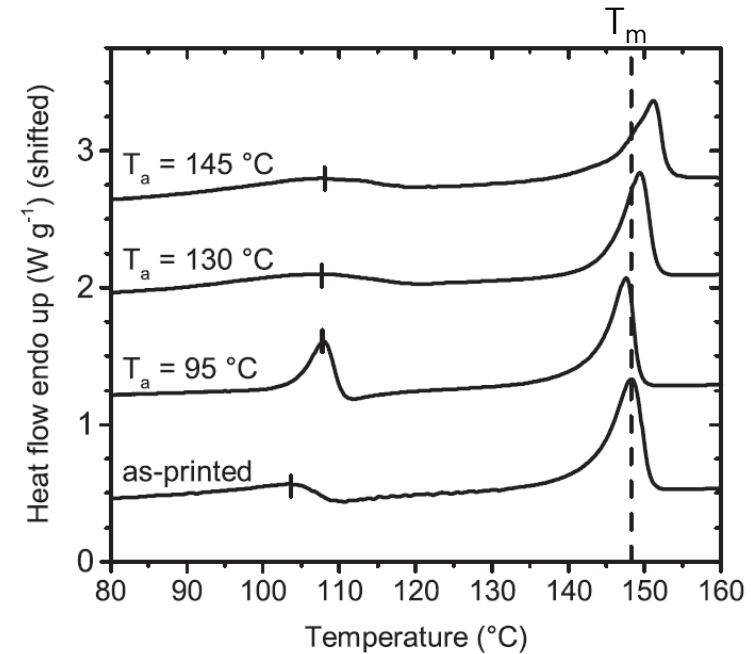
➔ First all inkjet-printed P(VDF-TrFE) actuators
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Device Performance – Morphology

■ X-ray diffraction



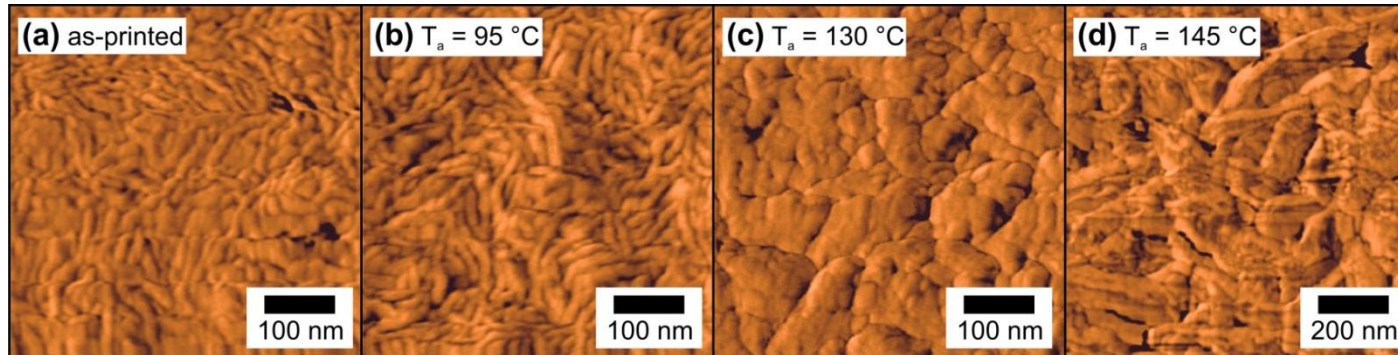
■ Differential scanning calorimetry



➔ Annealing @ 130 – 145 $^{\circ}\text{C}$: Predominant β -phase + larger crystallites

Device Performance – Morphology

■ AFM characterization

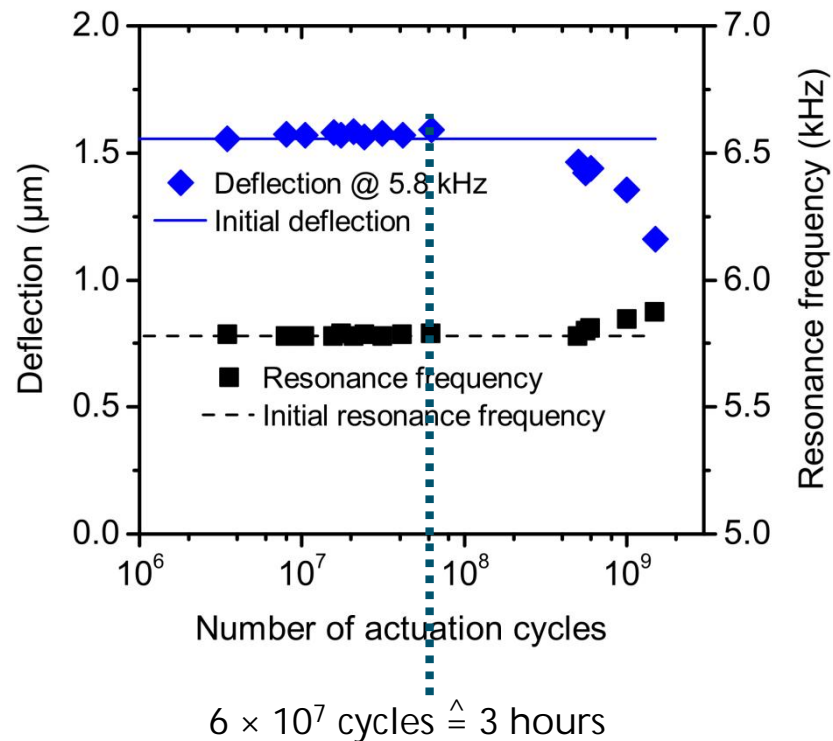


Sample	d_{31} (pm V ⁻¹)	P_{rem} ($\mu\text{C cm}^{-2}$)	Morphology from AFM	Crystallite size (nm)
95 °C	0.8 ± 0.04	0.1 ± 0.01	rod-like	21 ± 7
130 °C + Ar-Plasma	8.0 ± 0.2	5.8 ± 0.1	globular	63 ± 24
145 °C	6.6 ± 0.4	4.3 ± 0.4	globular	138 ± 62
Literature	$\approx 10 - 12$ [1]	≈ 8 [2]		≈ 180

➔ Process guidelines: Annealing → Morphology → d_{31} , P_{rem}

Device Stability – Cyclic Operation

- Cyclic stability test in air (1.5×10^9 cycles, 75 V @ f_{res})
- Realistic operation in disposable device < 3 hours

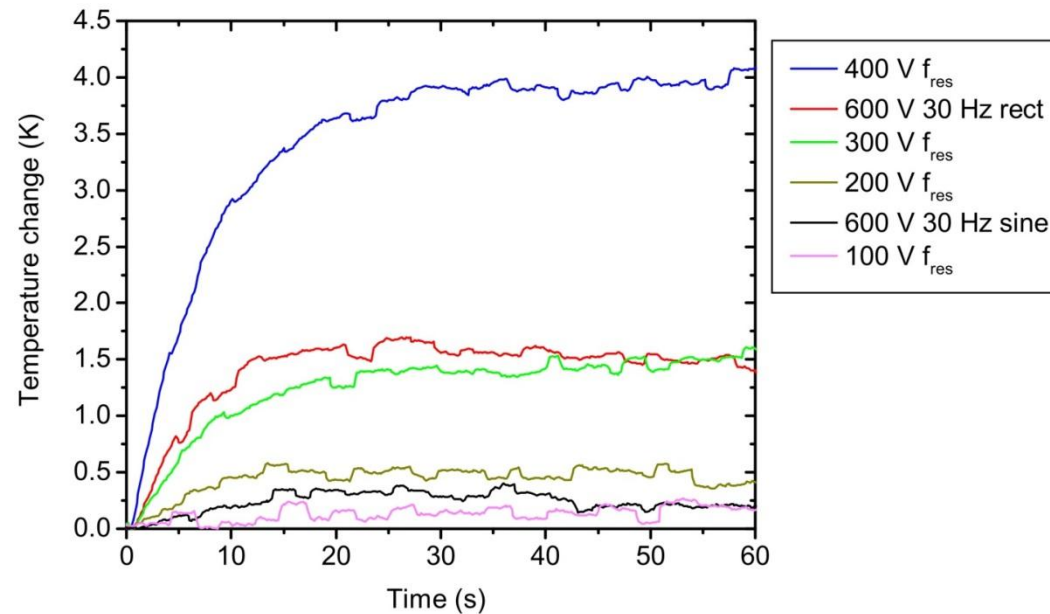
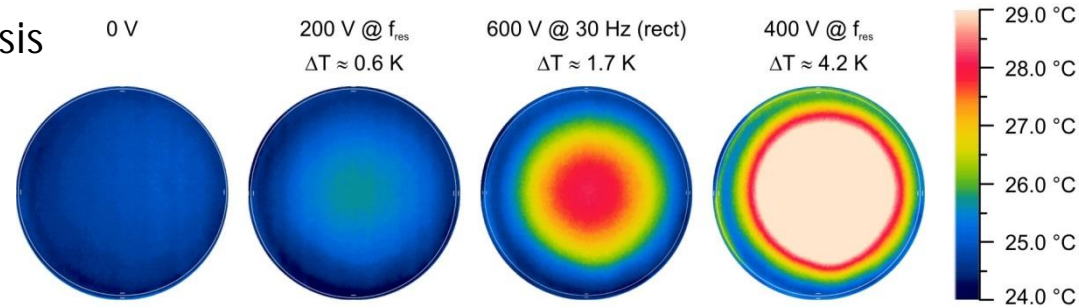


➔ Degradation for large cycle numbers (> 10⁸)

[Results obtained with silver electrodes]

Device Stability – Heat Generation

- Polarization hysteresis
→ Heat generation

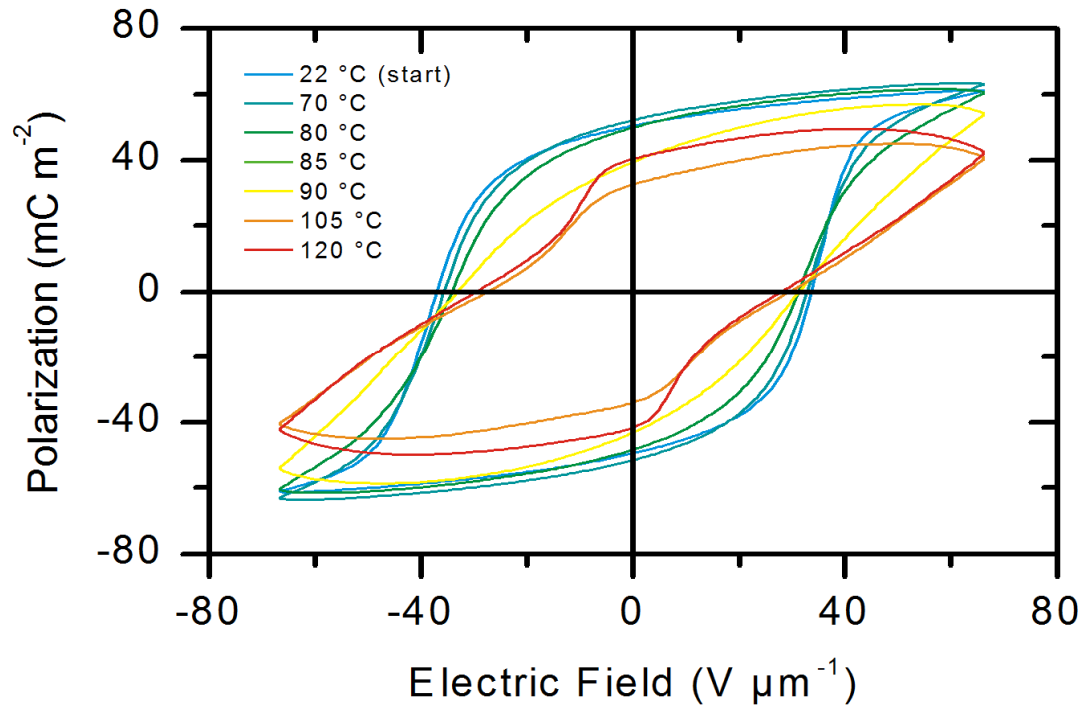


➔ Low heat generation ($\Delta T < 2$ K for most driving cases)

[Results obtained with silver electrodes]

Device Stability – Operating Temperature

- Operational stability @ elevated temperatures



➔ Stable operation up to ≈ 80 °C

[Results obtained with silver electrodes]